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CONFIRMATION NO. 6774

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| 10/552,262 | 10/05/2005 | 438 | 1792 | 33082M275 |
| RULE | | | | |
| APPLICANTS Kazuhide Hasebe, Tokyo-To, JAPAN; Mitsuhiro Okada, Tokyo-To, JAPAN; Takashi Chiba, Tokyo-To, JAPAN; Jun Ogawa, Tokyo-To, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/05643 04/20/2004 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2003-117664 04/22/2003 | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/20/2006 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/LAN VINH/</u> Examiner's Signature | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 9 | TOTAL CLAIMS 15 |
| INDEPENDENT CLAIMS 2 | | | | |
| ADDRESS SMITH, GAMBRELL & RUSSELL 1130 CONNECTICUT AVENUE, N.W., SUITE 1130 WASHINGTON, DC 20036 UNITED STATES | | | | |
| TITLE Method for removing silicon oxide film and processing apparatus | | | | |
| FILING FEE RECEIVED 1620 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |